

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Dureseti CHIDAMBARRAO, et al. Group Art Unit: 2814  
Appln. No. : 10/605,108 Examiner: PHAM, Long  
Filed : September 9, 2003 Confirmation No. 2107  
For : METHOD FOR REDUCED N+ DIFFUSION IN STRAINED SI  
ON SI/GE SUBSTRATE

**COMMENTS UNDER 37 C.F.R. 1.312**

Commissioner for Patents  
U.S. Patent and Trademark Office  
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Alexandria, VA 22314

Sir:

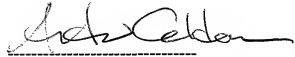
In response to the Notice of Allowability, mailed by the Patent and Trademark Office on May 18, 2008, Applicant wishes to clarify the record with respect to the allowed claims. Applicant notes that claims 16-1822-28 and 30-39 are pending and should be indicated as being allowed.

Applicant also wishes to clarify that the claims in the present application recite a combination of features, and the basis for patentability of these claims is based upon the totality of the features recited therein.

FIS920030183US1

Should the Examiner have any questions or comments about the above, he is respectfully requested to contact the undersigned at the below-listed telephone number.

Respectfully submitted,  
Dureseti CHIDAMBARRAO, et al

A handwritten signature in black ink, appearing to read "Andrew M. Calderon", written over a horizontal dashed line.

Andrew M. Calderon  
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